



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

August 27, 2004

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2828

Application No.: 10/026,637

Examiner: A. Rodriguez

Filed: December 27, 2001

Docket No.: 111587

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING METHOD
THEREOF

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired July 29, 2004, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 157770 in the amount of \$110.00 in payment for:

 X Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$420.00)
 Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

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Respectfully submitted,

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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
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